Docket No: 031948-6

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of)
Kenji ARAI et al.)
Application No. To be assigned) Attn: Applications
Filed: On even date) Branch
For: METHOD OF PROTECTING A)
SEMICONDUCTOR INTEGRATED CIRCUIT)
FROM PLASMA DAMAGE) Date: January 21, 2004

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited is enclosed.

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

Respectfully submitted,

Donald R. Studebaker

Registration No. 32,815

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Substitute for form 1449A/PTO		Complete if Known				
INFORMATION DISCLOSURE			LOSURE	Application Number	New Application	
STATEMENT BY APPLICANT		Filing Date	January 21, 2004			
		First Named Inventor	Kenji ARAI et al.			
(use as many sheets as necessary)	Art Unit					
		Examiner Name				
Sheet	1	of	1	Attorney Docket Number	031948-6	

	U.S. PATENT DOCUMENTS					
	Cite No.	U.S. Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
		Number - Kind Code ² (if known)		Applicant of Cited Document		
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Examiner Initials	Cite No. ¹	Foreign Patent Document Kind Code ⁵ Country Code ³ Number ⁴ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Application of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Τ¢
		JP 11-168196	06/22/1999	Takeuchi		Abstract
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		OTHER PRIOR	ART – NON PATENT	LITERATURE DOCUMENTS		
Examiner Initials	Cite No. ¹		he author (in CAPITAL LETTERS), title of the article (when appropriate), title of the ine, journal, serial, symposium, catalog, etc.)., date, page(s), volume-issue number(s), publisher, city and/or country where published.			T ²
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Examiner	Date	
Signature	Considered	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.